



JFW
PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Andrew Strachan et al.

Application No.: 10/659,421

Filed: September 10, 2003

For: METHOD OF IMPROVING THE
BREAKDOWN VOLTAGE OF A
DIFFUSED SEMICONDUCTOR
JUNCTION

Confirmation No.: 4626

Group Art Unit: 2812

Examiner: Stanetta D. Isaac

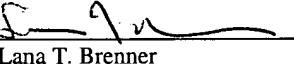
RESPONSE TO OFFICE ACTION
MAILED FEBRUARY 23, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 18, 2005.

STALLMAN & POLLOCK LLP

Dated: 08/18/05 By: 
Lana T. Brenner

Sir:

Please amend the above-identified application as follows:

Amendments to the claims are provided in the Listing of the Claims that begins on page 2 of this paper.

Remarks begin on page 3 of this paper.

Proposed drawing changes are attached.

08/26/2005 EHAILE1 00000016 10659421

01 FC:1253

1020.00 OP

Atty Docket No.: NSC1-M3200 [P05675]